

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination CLEMONS ET AL.	
		Examiner Igwe U. Anya	Art Unit 2825	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-6,451,626	09-2002	Lin, Charles W.C.	438/108
B	US-6,433,425	08-2002	Sarkhel, Amit K.	257/737
C	US-6,414,849	07-2002	Chiu, Anthony M.	361/760
D	US-6,662,442	12-2003	Matsui et al.	29/852
E	US-2004/0012934	01-2004	Jafari et al.	361/760
F	US-2004/0012938	01-2004	Sylvester et al.	361/794
G	US-5,829,125	11-1998	Fujimoto et al.	29/840
H	US-6,133,626	10-2000	Hawke et al.	257/686
I	US-6,140,707	10-2000	Plepy et al.	257/778
J	US-			
K	US-			
L	US-			
M	US-			

**FOREIGN PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N	JP 2002016214 A	01-2002	Japan	HAYASHI, KAZUYOSHI	H01L 25/065
O					
P					
Q					
R					
S					
T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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